



**ELECTRONIC COPY**

LG784683759  
Report verification at igi.org



March 23, 2026

IGI Report Number **LG784683759**

Description **LABORATORY GROWN DIAMOND**

Shape and Cutting Style **PEAR BRILLIANT**

Measurements **8.42 X 5.62 X 3.61 MM**

**GRADING RESULTS**

Carat Weight **1.04 CARAT**

Color Grade **D**

Clarity Grade **VVS 2**

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**ADDITIONAL GRADING INFORMATION**

Polish **EXCELLENT**

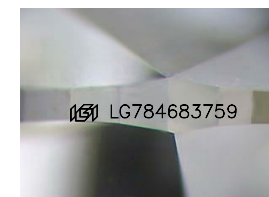
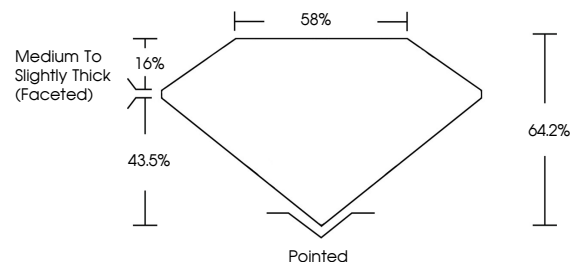
Symmetry **EXCELLENT**

Fluorescence **NONE**

Inscription(s) **IGI LG784683759**

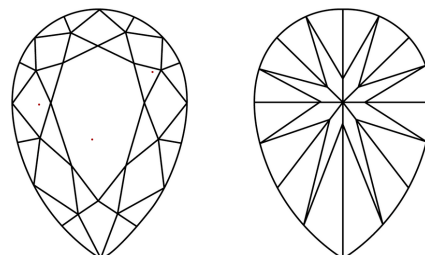
Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.  
Type IIa

**PROPORTIONS**



Sample Image Used

**CLARITY CHARACTERISTICS**



**KEY TO SYMBOLS**

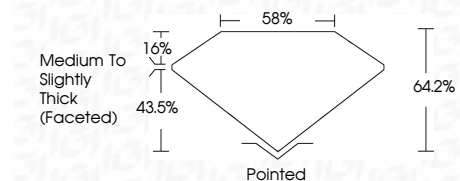
Red symbols indicate internal characteristics.  
Green symbols indicate external characteristics.

**COLOR**

D E F G H I J Faint Very Light Light

**CLARITY**

FL	IF	VVS <sup>1-2</sup>	VS <sup>1-2</sup>	SI <sup>1-2</sup>	I <sup>1-3</sup>
Flawless	Internally Flawless	Very Very Slightly Included	Very Slightly Included	Slightly Included	Included



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Symmetry **EXCELLENT**

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**IGI**



March 23, 2026  
IGI Report No LG784683759  
PEAR BRILLIANT  
8.42 X 5.62 X 3.61 MM  
Carat Weight 1.04 CARAT  
Color Grade D  
Clarity Grade VVS 2  
Depth 43.5%  
Table 16%  
Girdle Medium to Slightly Thick (Faceted)  
Culet Pointed  
Polish EXCELLENT  
Symmetry EXCELLENT  
Fluorescence NONE  
Inscription(s) IGI LG784683759  
Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.  
Type IIa